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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10057206	FILING DATE 01/25/2002	CLASS 051	SUBCLASS 309	GAU 1755	EXAMINER
**APPLICANTS: Small Robert; Chen Zhefei;					
**CONTINUING DATA VERIFIED:					
** FOREIGN APPLICATIONS VERIFIED:					
PG-PUB <input type="checkbox"/>		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO M-12178 US	
Verified and Acknowledged Examiners's initials					
TITLE : Compositions for chemical-mechanical planarization of noble-metal-featured substrates, associated methods, and substrates produced by such methods					
U.S. DEPT. OF COMM./PAT & TM.-PTO-435L (Rev. 12-94)					

Best Available Copy

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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